## Notice of References Cited Application/Control No. 10/663,821 Examiner Arnel C. Lavarias Applicant(s)/Patent Under Reexamination NAMII, YASUSHI Applicant(s)/Patent Under Reexamination NAMII, YASUSHI Page 1 of 1

## **U.S. PATENT DOCUMENTS**

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
	Α	US-4,353,618	10-1982	Hagner et al.	359/385
	В	US-5,748,367	05-1998	Lucke et al.	359/385
	O	US-2003/0201378	10-2003	Ishikawa et al.	250/201.3
	۵	US-3,790,249	02-1974	Treace, Harry T.	359/388
	Е	US-			
	F	US-			
	G	US-			
	Н	US-			
	1	US-			
	J	US-			
	К	US-			
	L	US-			
	М	US-			

## FOREIGN PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
	N	JP09274141A	10-1997	Japan	Tomioka, K.	G02B021/06
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	R					
	S					
	T					

## **NON-PATENT DOCUMENTS**

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*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)							
	U	NONE							
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\*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)

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